

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date	June 23, 2008	

In re the Application of

Takaaki NODA et al.

Group Art Unit: 1792

Application No.: 10/587,500

Examiner:

K. STOUFFER

Filed:

July 27, 2006

Docket No.: 128807

For:

METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND APPARATUS FOR

PROCESSING SUBSTRATE

LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION OF TIME UNDER 37 C.F.R. §1.136(a) AND TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired May 22, 2008, an extension of time for a period of 1 month is hereby requested. Attached hereto is our Check No. 206995 in the amount of \$120 in payment for:

Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1050.00)

X	Extension fee for response within first month pursuant to §1.136(a) (\$120.00)
	Extension fee for response within second month pursuant to §1.136(a) (\$460.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment

associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted,

James A. Oliff

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OLIFF & BERRIDGE, PLC P.O. Box 320850 Alexandria, Virginia 22320-4850 Telephone: (703) 836-6400

JAO:ABF/mld

DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461